

Supporting Information

Wetting Properties and SERS Applications of ZnO/Ag Nanowire Arrays Patterned by Screen-Printing Method

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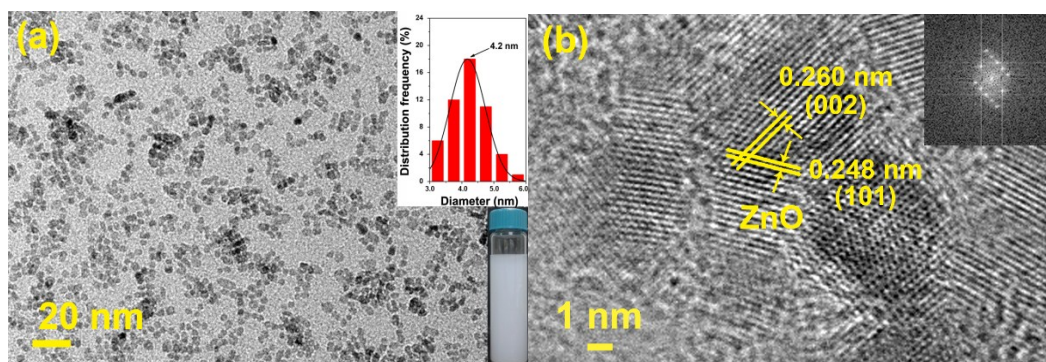


Fig. S1 The TEM image of ZnO NPs, the insert are the photograph of ZnO NPs and alcohol dispersion system and the corresponding histogram of particle size distributions (a); the HRTEM image of ZnO NPs (b).

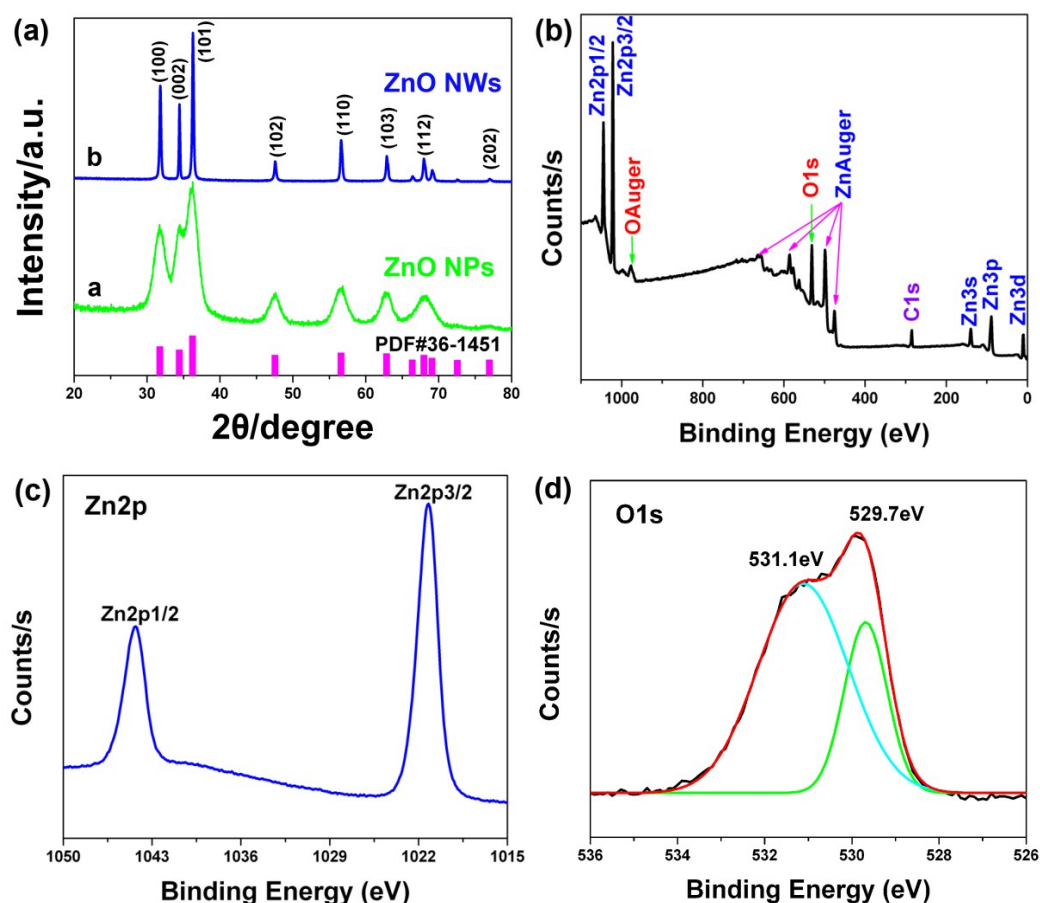


Fig. S2 XRD pattern of ZnO NPs (curve a) and the as-obtained ZnO Nanowires (curve b), together with standard JCPDS card (36-1451, pink lines, a); XPS wide survey spectra of ZnO Nanowires obtained by hydrothermal method (b); and XPS spectra of the zinc Zn 2p peaks (c) and oxygen O 1s peaks (d).

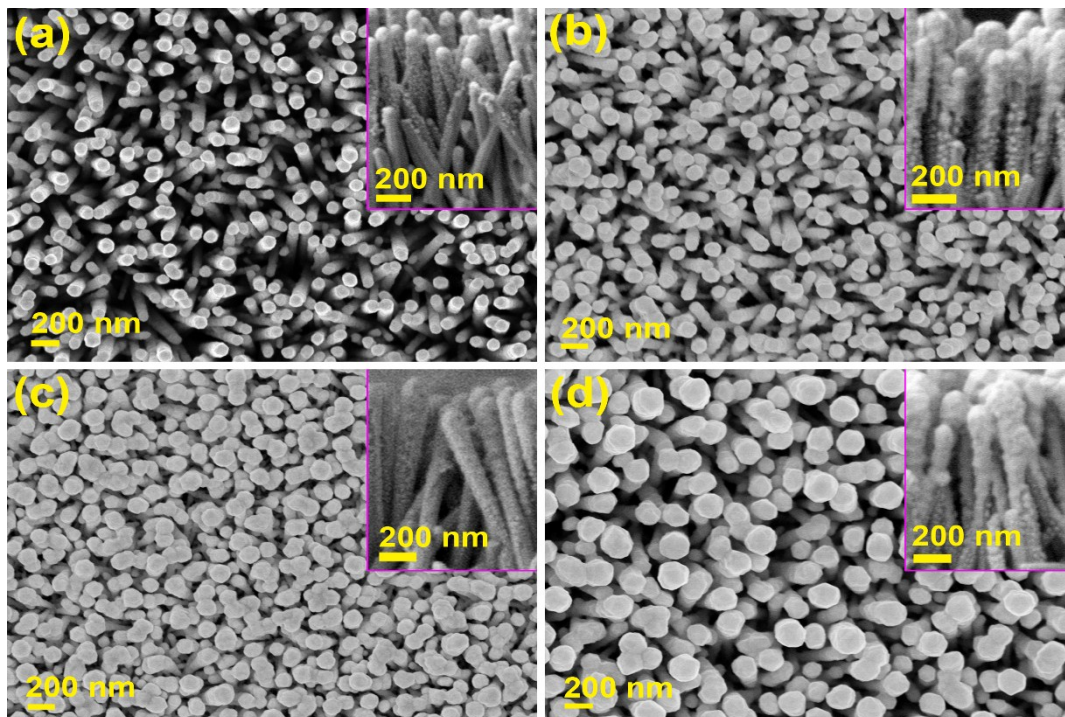


Fig. S3 The SEM images of ZnO/Ag NWs arrays prepared on PET with a sputtering duration of 3 min (a), 6 min (b), 9 min (c) and 15 min (d); and the insets show their corresponding cross-sectional SEM images, respectively.

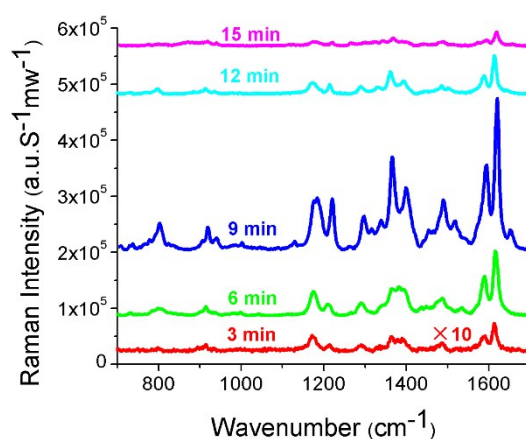


Fig. S4 The SERS spectra collected on ZnO/Ag NWs arrays prepared on PET with different sputtering durations (3 min, 6 min, 9 min, 12 min and 15 min) after being immersed in 10^{-5} M MG solution.

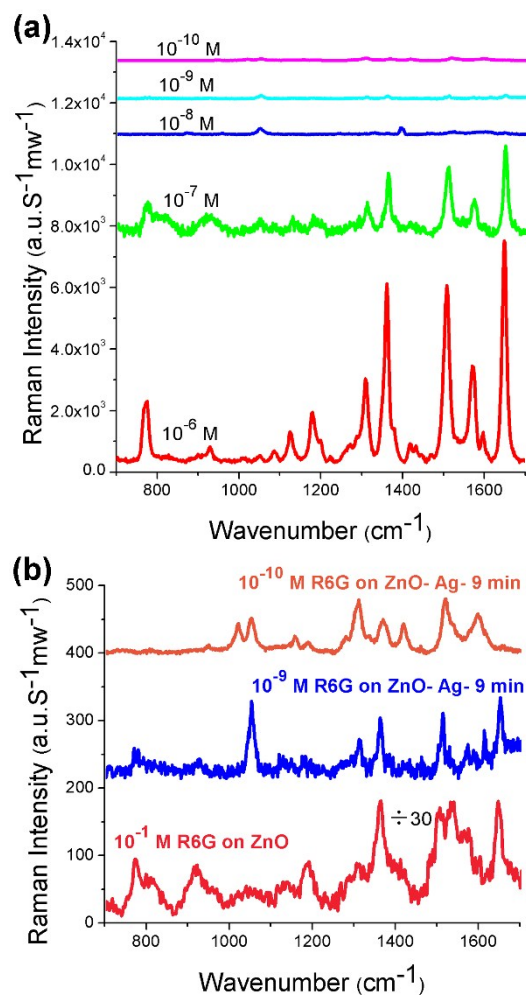


Fig. S5 The SERS spectra of R6G collected on the ZnO/Ag NWs arrays prepared on PET with a sputtering duration of 9 min, which was exposed to different R6G concentrations (from 10⁻⁶ to 10⁻¹⁰ M, left); right, the enlarged SERS spectra of R6G collected on the above substrate exposed to 10⁻⁹ and 10⁻¹⁰ R6G solution, and the Raman spectra of R6G collected on the patterned ZnO NWs arrays prepared on PET without Ag sputtering exposed to 10⁻¹ M R6G solution.

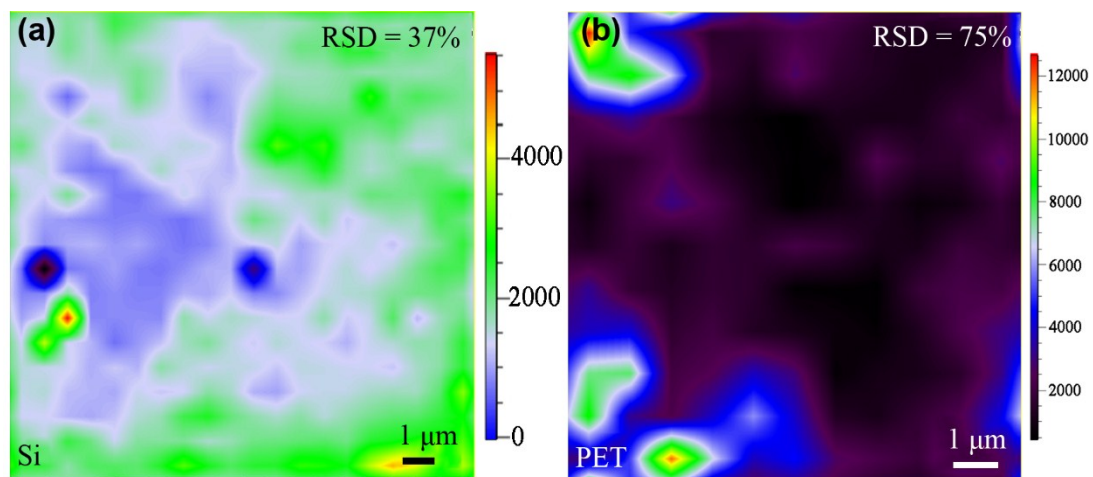


Fig. S6 Two Raman mappings of randomly selected areas on 3D ZnO/Ag-9 substrates on Si and PET, respectively.

Table S1 Reported detection limits and enhancement factors on some noble metal/semiconductor and printed SERS substrates

substrate	Raman molecules	detection limit	enhancement factor	Ref.
Ag NPs decorated TiO ₂ NRs	MG	10 ⁻¹²	4.36×10 ⁵	1
Ag NCs on ZnO NDAs	MG	10 ⁻¹⁷	1×10 ⁶	2
Ag- decorated ZnO NPAs	R6G	10 ⁻⁷	1×10 ⁶	3
Au Semishells decorated TiO ₂ Sphere arrays	R6G	-	1.4×10 ⁵	4
Screen printed Ag NPs	R6G	10 ⁻¹²	4.4×10 ⁶	5
Screen printed Au–Ag bimetallic microfluidic	R6G	1.1×10 ⁻¹³	4.4×10 ⁶	6
ZnO/Ag NWAs patterned by screen-printing	MG	10⁻¹²	2.5×10¹⁰	this study
	R6G	10⁻¹⁰	1.6×10⁷	

NR: nanorod, NC: anocluster, NDA: nanodome array, NPA: nanoplate array, NSA: nanosphere array, NWA: nanowire array

Reference:

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